

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

Hideshi NISHIKAWA et al.

Serial No.: not yet assigned

Filed: March 26, 2004

For: SILICON ANNEALED WAFER AND SILICON EPITAXIAL WAFER

INFORMATION DISCLOSURE STATEMENT

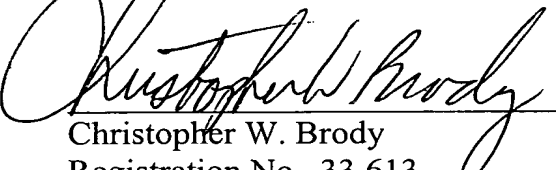
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

Applicants respectfully submit that this disclosure is being made with the filing of the application, hence, no fee is required.

Respectfully submitted,
CLARK & BRODY


Christopher W. Brody
Registration No. 33,613

Customer No. 22902
1750 K Street NW, Suite 600
Washington DC 20006
Telephone: 202-835-1111
Facsimile: 202-835-1755

Docket No.: 12054-0025
Date: March 26, 2004

FORM PTO-1449 INFORMATION DISCLOSURE CITATION		Attorney Docket: 12010-0025		Serial No.: not yet assigned			
		Applicant: Hideshi NISHIKAWA et al.					
		Filing Date: March 26, 2004		Group: not yet assigned			
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub- Class	Filing Date
FOREIGN PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Country	Class	Sub- Class	Translation Yes No
		10-098047	04/14/1998	Japan			X
		11-189493	07/13/1999	Japan			X
		2001-199795	07/24/2001	Japan			X
		2002-187794	07/05/2002	Japan			X
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
		K. Nakai; "NITROGEN AND CARBON EFFECT ON THE FORMULATION OF GROWN-IN DEFECTS AND OXYGEN PRECIPITATION BEHAVIOR"; The 52 nd Conference of the Japanese Association for Crystal Growth, Bulk Growth Section Meeting; February 8, 2000, pages 6-9					

Examiner:	Date Considered:
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.	